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STATEMENT BY APPLICANT First Named Inventor Yeo, et al. Art Unit 2891 (Use as many sheets as necessary) **Examiner Name** Chaudhari, Chandra P. Sheet 1 of 4 Attorney Docket Number TSM03-0421

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| IN                     | FORMATIO                          | N DISCL | OSURE | Filing Date            | June 27, 2003         |  |
| STATEMENT BY APPLICANT |                                   |         |       | First Named Inventor   | Yeo, et al.           |  |
|                        |                                   |         |       | Art Unit               | 2891                  |  |
|                        | (Use as many sheets as necessary) |         |       | Examiner Name          | Chaudhari, Chandra P. |  |
| Sheet                  | 2                                 | of      | 4     | Attorney Docket Number | TSM03-0421            |  |

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|                               | ATEMENT B                         |               |                      | First Named Inventor                                | Yeo, et al.  |  |
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